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OCT 02 2009

Application No. 10/568,727

**Patent**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
**(Case No. 100191CIP)**

First Inventor: Nam, Chul Woo

Serial No.: 10/568,727

Filing Date: 02/17/2006

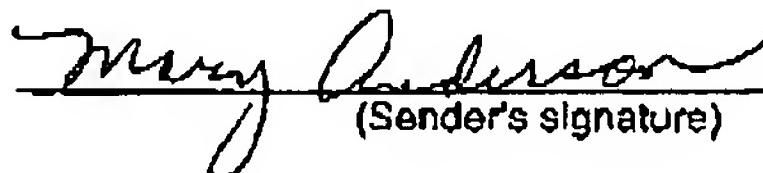
Title: CHEMICAL-MECHANICAL  
POLISHING COMPOSITION AND  
METHOD FOR USING THE  
SAME

Examiner: Vinh. Lan

Art Unit: 1792

**Certificate of Facsimile Transmission**

I, Mary Anderson, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on OCT 02 2009.



Mary Anderson  
(Sender's signature)

**RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir,

This paper is submitted in response to the Office Action mailed July 2, 2009. Please consider the following remarks and enter the following amendments in the record for this application.

**Amendments to the Claims** are reflected in the listing of claims, and begin on page 2 of this paper.

**Remarks** begin on page 5 of this paper.